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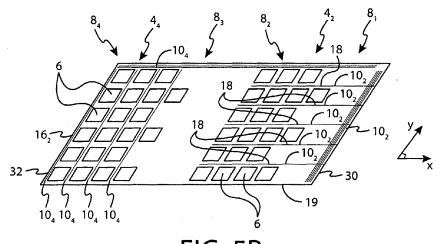


FIG. 5B

(57) Abstract: An apparatus comprising: a sensing arrangement comprising: a first array of capacitive sensor electrodes comprising a first plurality of distinct capacitive sensor electrodes distributed in a first layer over a first sensing area; first conductive traces operatively connected to the first plurality of distinct capacitive sensor electrodes; a second array of capacitive sensor electrodes comprising a second plurality of distinct capacitive sensor electrodes distributed in a second layer over a second sensing area, wherein the first layer and the second layer are different layers; and second conductive traces operatively connected to the second plurality of distinct capacitive sensor electrodes.



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#### **TITLE**

### **TOUCH SENSOR ARRAY**

#### TECHNOLOGICAL FIELD

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Embodiments of the present invention relate to an apparatus. In particular, they relate to an apparatus comprising a plurality of capacitive sensor electrodes distributed over a sensing area.

#### **BACKGROUND**

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Current touch sensitive displays may use a plurality of capacitive sensor electrodes distributed over a sensing area. The capacitive sensor electrodes sense a proximal grounded object such as a user's finger touching the sensing area.

### 15 BRIEF SUMMARY

According to various, but not necessarily all, embodiments of the invention there is provided an apparatus comprising: a sensing arrangement comprising: a first array of capacitive sensor electrodes comprising a first plurality of distinct capacitive sensor electrodes distributed in a first layer over a first sensing area; first conductive traces operatively connected to the first plurality of distinct capacitive sensor electrodes; a second array of capacitive sensor electrodes comprising a second plurality of distinct capacitive sensor electrodes distributed in a second layer over a second sensing area, wherein the first layer and the second layer are different layers; and second conductive traces operatively connected to the second plurality of distinct capacitive sensor electrodes.

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According to various, but not necessarily all, embodiments of the invention there is provided a method comprising: arranging capacitive sensor electrodes for touch sensing over a sensing area as a first sub-set of the capacitive sensor electrodes, distributed in a first layer over a first sub-set of the sensing area and as second sub-set of the capacitive sensor electrodes, distributed in second layer over a second sub-set of the sensing area; and

sensing area, and

routing first conductive traces to the first sub-set of the capacitive sensor electrodes and second conductive traces to the second sub-set of the capacitive sensor electrodes.

According to various, but not necessarily all, embodiments of the invention there is provided apparatus and methods as defined in the appended claims.

### **BRIEF DESCRIPTION**

For a better understanding of various examples of embodiments of the present invention reference will now be made by way of example only to the accompanying drawings in which:

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Fig 1 illustrates an example of an apparatus comprising a sensing arrangement comprising a plurality of capacitive sensor electrodes distributed over a sensing area in at least two different layers;

Fig 2 illustrates an example of a sensing arrangement comprising

a plurality of capacitive sensor electrodes distributed over a sensing area in at least two different layers;

- 5 Fig 3 schematically illustrates an example of a cross-section through a sensing arrangement;
  - Figs 4A and 4B illustrate an example of layers of a sensing arrangement and the arrangement, according to a first embodiment, of capacitive sensor electrodes and conductive traces within the layers;
  - Fig 4C illustrates in more detail an example, according to the first embodiment, of a configuration of conductive traces operatively connected to capacitive sensor electrodes in a lower layer;
- Figs 5A and 5B illustrate an example of layers of a sensing arrangement and the arrangement, according to a second embodiment, of capacitive sensor electrodes and conductive traces within the layers;
  - Fig 5C illustrates in more detail an example, according to the second embodiment, of a configuration of conductive traces operatively connected to capacitive sensor electrodes in a lower layer;
  - Figs 6A and 6B illustrate an example of layers of a sensing arrangement and the arrangement, according to a third embodiment, of capacitive sensor electrodes and conductive traces within the layers;
    - Fig 6C and 6D illustrates in more detail an example, according to the third embodiment, of the configurations of conductive traces operatively connected to capacitive sensor electrodes in a lower layer; Fig 7 illustrates an example of a method;
    - Fig 8A illustrates an example of a touch panel module;
- Fig 8B illustrates an example of a touch sensitive display module; and
  - Fig 8C illustrates an example of an electronic device.

#### **DETAILED DESCRIPTION**

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- The Figures illustrate an apparatus 2 comprising: a sensing arrangement 5 comprising: a first array 4<sub>1</sub> of capacitive sensor electrodes 6 comprising a first plurality N<sub>1</sub> of distinct capacitive sensor electrodes 6 distributed in a first layer 16<sub>1</sub> over a first sensing area 8<sub>1</sub>; first conductive traces 10<sub>1</sub> operatively connected to the first plurality N<sub>1</sub> of distinct capacitive sensor electrodes 6;
- a second array 4<sub>2</sub> of capacitive sensor electrodes 6 comprising a second plurality N<sub>2</sub> of distinct capacitive sensor electrodes 6 distributed in a second layer 16<sub>2</sub> over a second sensing area 8<sub>2</sub>, wherein the first layer 16<sub>1</sub> and the second layer 16<sub>2</sub> are different layers; and second conductive traces 10<sub>2</sub> operatively connected to the second plurality N<sub>2</sub> of distinct capacitive sensor electrodes 6.
- Fig 1 illustrates an apparatus 2 comprising: a sensing arrangement 5 comprising a plurality of capacitive sensor electrodes 6 distributed over a sensing area 8 and conductive traces 10 at least partially distributed over the sensing area 8.

In this example, the apparatus 2 overlies a display 40 and operates as a capacitive touch panel for the display 40. The display 40 and the apparatus 2 in combination form a touch sensitive display configured

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to detect a variation in capacitance arising from proximity of a user input device 42 to one or more of the plurality of capacitive sensor electrodes 6.

The sensing arrangement 5 is configured to sense a variation in capacitance arising from proximity of a user input device 42 at or over the sensing area 8 of a touch surface 7. In this example the user input device 42 is a user's finger.

The apparatus 2 is configured to sense the (x, y) position of the user's finger within the sensing area 8 when it touches the sensing area 8 of the touch surface 7. In some examples, the apparatus 2 may additionally provide a (z) position of the user's finger when it is close to but not touching the sensing area 8 of the touch surface 7 and/or provide an (x, y) position of the user's finger when it is close to but not yet touching the sensing area of the touch surface 7. The apparatus 2 may therefore provide for not only two-dimensional sensing but also three-dimensional sensing.

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- The apparatus 2 may optionally comprise a first shield electrode 12 overlying conductive traces 10 at least outside the sensing area 8; and a second shield electrode 20 underlying, in the sensing area 8, the conductive traces 10 and the capacitive sensor electrodes 6.
- In this apparatus 2, the capacitive sensor electrodes 6 distributed over the sensing area 8 comprise multiple arrays  $4_n$  of capacitive sensor electrodes 6, each array  $4_n$  comprising a plurality  $N_n$  of distinct capacitive sensor electrodes 6. At least some of the multiple arrays  $4_n$  of capacitive sensor electrodes 6 occupy different layers 16.
- For example, as illustrated in Figs 4A, 4B, 5A, 5B, 6A, 6B, a first array 4<sub>1</sub> of capacitive sensor electrodes 6 comprising a first plurality N<sub>1</sub> of distinct capacitive sensor electrodes 6 is distributed in a first layer 16<sub>1</sub> over a first sensing area 8<sub>1</sub>. A second array 4<sub>2</sub> of capacitive sensor electrodes 6 comprising a second plurality N<sub>2</sub> of distinct capacitive sensor electrodes 6 is distributed in a second layer 16<sub>2</sub> over a second sensing area 8<sub>2</sub>. The first layer 16<sub>1</sub> and the second layer 16<sub>2</sub> are different layers.
- First conductive traces  $10_1$  are operatively connected to the first plurality  $N_1$  of distinct capacitive sensor electrodes 6 and second conductive traces  $10_2$  are operatively connected to the second plurality  $N_2$  of distinct capacitive sensor electrodes 6.
- The first array 4<sub>1</sub> of capacitive sensor electrodes 6 is configured to sense the (x, y) position of the user's finger within the first sensing area 8<sub>1</sub> when it touches the first sensing area 8<sub>1</sub> of the touch surface 7. In some examples, the apparatus 2 may additionally provide a (z) position of the user's finger when it is close to but not touching the first sensing area 8<sub>1</sub> of the touch surface 7 and/or provide an (x, y) position of the user's finger when it is close to but not yet touching the first sensing area 8<sub>1</sub> of the touch surface 7. The apparatus 2 may therefore provide for not only two-dimensional sensing but also three-dimensional sensing.

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The second array  $4_2$  of capacitive sensor electrodes 6 is configured to sense the (x, y) position of the user's finger within the second sensing area  $8_2$  when it touches the second sensing area  $8_2$  of the touch surface 7. In some examples, the apparatus 2 may additionally provide a (z) position of the user's finger when it is close to but not touching the second sensing area  $8_2$  of the touch surface 7 and/or provide an (x, y) position of the user's finger when it is close to but not yet touching the second sensing area  $8_2$  of the touch surface 7. The apparatus 2 may therefore provide for not only two-dimensional sensing but also three-dimensional sensing.

- Figs 4A and 4B illustrate a first array 4<sub>1</sub> of capacitive sensor electrodes 6 and a second array 4<sub>2</sub> of capacitive sensor electrodes 6, that occupy different layers 16 and are used in combination to detect touch input at or over the sensing area 8.
- Fig 4A illustrates an example of a first array 4<sub>1</sub> of capacitive sensor electrodes 6 comprising a first plurality N<sub>1</sub> of distinct capacitive sensor electrodes 6 distributed in a first layer 16<sub>1</sub> over a first sensing area 8<sub>1</sub>. First conductive traces 10<sub>1</sub> are operatively connected to the first plurality N<sub>1</sub> of distinct capacitive sensor electrodes 6.
- Fig 4B illustrates an example of a second array 4<sub>2</sub> of capacitive sensor electrodes 6 comprising a second plurality N<sub>2</sub> of distinct capacitive sensor electrodes 6 distributed in a second layer 16<sub>2</sub> over a second sensing area 8<sub>2</sub>. The first layer 16<sub>1</sub> and the second layer 16<sub>2</sub> are different layers. Second conductive traces 10<sub>2</sub> area operatively connected to the second plurality N<sub>2</sub> of distinct capacitive sensor electrodes 6.

The first sensing area  $8_1$  and the second sensing area  $8_2$  do not overlap.

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Referring to Fig 4B, the second layer 16<sub>2</sub> underlies the first layer 16<sub>1</sub>.

The first array  $4_1$  of capacitive sensor electrodes 6 is positioned proximal to a first edge 30 of the sensing arrangement 5 and the second array  $4_2$  of capacitive sensor electrodes 6 is positioned distal from the first edge 30 of the sensing arrangement 5.

The second conductive traces  $10_2$  are routed from the first edge 30 underneath the first array  $4_1$  of capacitive sensor electrodes 6 in the first layer  $16_1$  to the second array  $4_2$  of capacitive sensor electrodes 6 in the second layer  $16_2$ . The second conductive traces  $10_2$  where they are routed underneath the first array  $4_1$  comprise conductive trace portions 18 that have a higher conductivity per unit length than the first conductive traces  $10_1$ .

The higher conductivity conductive trace portions 18 may, for example, be wider than the first conductive traces  $10_1$  where they extend across an area 19 overlapping the first array  $4_1$  of capacitive sensor electrodes 6.

Fig 4C illustrates in more detail an example, according to the first embodiment, of a configuration, in a lower layer  $16_2$ , of second conductive traces  $10_2$  operatively connected to the second array  $4_2$  of capacitive sensor electrodes 6.

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For clarity of illustration, only one row/column of the second array  $4_2$  of capacitive sensor electrodes 6 is explicitly illustrated and only some of the capacitive sensor electrodes 6 in that row/column are illustrated. Only the second conductive traces  $10_2$  operatively connected to the illustrated capacitive sensor electrodes 6 are explicitly illustrated.

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In Fig 4C, the second conductive traces  $10_2$  where they are routed underneath the first array  $4_1$  of capacitive sensor electrodes 6 comprise wider portions 18 that have a higher conductivity per unit length than the first conductive traces  $10_1$ . The higher conductivity conductive trace portions 18 are, in this example, wider than the first conductive traces  $10_1$  where they extend across the area 19 overlapping the first array  $4_1$  of capacitive sensor electrodes 6. Bends in the second conductive traces  $10_2$  are used to route the higher conductivity portions 18 of the second conductive traces  $10_2$  underneath capacitive sensor electrodes 6 of the first array  $4_1$  of capacitive sensor electrodes 6

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Figs 5A and 6A illustrate a first array  $4_1$  of capacitive sensor electrodes 6 and a third array  $4_3$  of capacitive sensor electrodes 6, that occupy the same layer  $16_1$  and are used in combination to detect touch input. Fig 5B and 6B illustrate a second array  $4_2$  of capacitive sensor electrodes 6 and a fourth array  $4_4$  of capacitive sensor electrodes 6, that occupy the same layer  $16_2$ .

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The first array  $4_1$  of capacitive sensor electrodes 6, the third array  $4_3$  of capacitive sensor electrodes 6, the second array  $4_2$  of capacitive sensor electrodes 6 and the fourth array  $4_4$  of capacitive sensor electrodes 6 are used in combination to detect touch input in or over the sensing area 8.

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The third array  $4_3$  of capacitive sensor electrodes 6 comprises a third plurality  $N_3$  of distinct capacitive sensor electrodes 6 distributed in the first layer  $16_1$  over a third sensing area  $8_3$ . Third conductive traces  $10_3$  are operatively connected to the third plurality  $N_3$  of distinct capacitive sensor electrodes 6.

The fourth array  $4_4$  of capacitive sensor electrodes 6 comprises a fourth plurality  $N_4$  of distinct capacitive sensor electrodes 6 distributed, in the second layer  $16_2$ , over a fourth sensing area  $8_4$ . Fourth conductive traces  $10_4$  are operatively connected to the fourth plurality  $N_4$  of distinct capacitive sensor electrodes 6.

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The first array  $4_1$  of capacitive sensor electrodes 6 is configured to sense at least two positional components (x, y) of a touch input that positions the touch input within the first sensing area  $8_1$ . The second array  $4_2$  of capacitive sensor electrodes 6 configured to sense at least two positional components (x,y) of a touch input that positions the touch input within the second sensing area  $8_2$ . The third array  $4_3$  of capacitive sensor electrodes 6 is configured to sense at least two positional components (x, y) of a touch

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input that positions the touch input within the third sensing area  $8_3$ . The fourth array  $4_4$  of capacitive sensor electrodes 6 configured to sense at least two positional components (x,y) of a touch input that positions the touch input within the fourth sensing area  $8_4$ .

- The first sensing area  $8_1$ , the second sensing area  $8_2$ , the third sensing area  $8_3$  and the fourth sensing area  $8_4$  are non-overlapping or substantially non-overlapping.
  - Referring to Figs 5A and 5B, the first layer 16<sub>1</sub> and the second layer 16<sub>2</sub> may be integrated into a single apparatus 2. Referring to Figs 6A and 6B, the first layer 16<sub>1</sub> and the second layer 16<sub>2</sub> may be integrated into a single apparatus 2.

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- Referring to Figs 5A and 5B, the first array  $4_1$  is positioned adjacent a first edge 30 and the third array  $4_3$  is positioned distal from the first edge 30 and distal from a second edge 32 that opposes the first edge 30.
- In this example, the first array  $4_1$  and the third array  $4_3$  have the same layout pattern of capacitive sensor electrodes 6, however the third array  $4_3$  is shifted in the first direction (x).
- The first conductive traces 10<sub>1</sub> extend parallel to a first direction (x) from an edge 30 into the first sensing area 8<sub>1</sub>. The first conductive traces 10<sub>1</sub> are separated in a second direction (y) (orthogonal to the x direction) so that the first conductive traces 10<sub>1</sub> are distributed over the first sensing area 8<sub>1</sub>.

The third conductive traces  $10_3$  extend parallel to the first direction (x), from the first edge 30, along a side 34 orthogonal to the first edge 30 outside the sensing area 8. The third conductive traces  $10_3$  are grouped together along the side 34 and do not pass over but run beside the first sensing area  $8_1$ .

The third conductive traces  $10_3$  then extend from the side 34 in the second direction (y) into the third sensing area  $8_3$ . The third conductive traces  $10_3$  are separated in the first direction (x) so that the third conductive traces  $10_3$  are distributed over the third sensing area  $8_3$ .

- The second conductive traces  $10_2$  extend, from the first edge 30, parallel to the first direction (x) underneath the first sensing area  $8_1$  into the second sensing area  $8_2$ . The second conductive traces  $10_2$  are separated in a second direction (y) so that the second conductive traces  $10_2$  are distributed over the first sensing area  $8_1$  and the second sensing area  $8_2$ .
- The second conductive traces  $10_2$  comprise conductive trace portions 18 that have a higher conductivity per unit length than the first conductive traces  $10_1$ .
  - The higher conductivity conductive trace portions 18 may, for example, be wider than the first conductive traces  $10_1$  where they extend across an area 19 overlapping the first array  $4_1$  of capacitive sensor electrodes 6.

Fig 5C illustrates in more detail an example, according to the second embodiment, of a configuration, in a lower layer  $16_2$ , of second conductive traces  $10_2$  operatively connected to the second array  $4_2$  of capacitive sensor electrodes 6.

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For clarity of illustration, only one row/column of the second array  $4_2$  of capacitive sensor electrodes 6 is explicitly illustrated and only some of the capacitive sensor electrodes 6 in that row/column are illustrated. Only the second conductive traces  $10_2$  operatively connected to the illustrated capacitive sensor electrodes 6 are explicitly illustrated.

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In Fig 5C, the second conductive traces  $10_2$  where they are routed underneath the first array  $4_1$  of capacitive sensor electrodes 6 comprise wider portions 18 that have a higher conductivity per unit length than the first conductive traces  $10_1$ . The higher conductivity conductive trace portions 18 are, in this example, wider than the first conductive traces  $10_1$  where they extend across the area 19 overlapping the first array  $4_1$  of capacitive sensor electrodes 6. Bends in the second conductive traces  $10_2$  are used to route the higher conductivity portions 18 of the second conductive traces  $10_2$  underneath capacitive sensor electrodes 6 of the first array  $4_1$  of capacitive sensor electrodes 6

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The fourth conductive traces  $10_4$  extend parallel to the first direction (x), from the first edge 30, along the side 34 orthogonal to the first edge 30 outside the sensing area 8. The fourth conductive traces  $10_4$  are grouped together along the side 34 and do not pass over, but pass beside, the first sensing area  $8_1$  and the second sensing area  $8_2$ .

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The fourth conductive traces  $10_4$  then extend from the side 34 in the second direction (y) into the fourth sensing area  $8_4$ . The fourth conductive traces  $10_4$  are separated in the first direction (x) so that the fourth conductive traces  $10_4$  are distributed over the fourth sensing area  $8_4$ .

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Referring to Figs 6A and 6B, the first array  $4_1$  is positioned adjacent a first edge 30 and the third array  $4_3$  is positioned adjacent the second edge 32 that opposes the first edge 30.

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In this example, the first array  $4_1$  and the third array  $4_3$  have the same layout pattern of capacitive sensor electrodes 6, however the third array  $4_3$  is rotated 180 degrees relative to the first array  $4_1$ .

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The first array  $4_1$  of capacitive sensor electrodes 6 is positioned proximal to a first edge 30 of the sensing arrangement 5 and the second array  $4_2$  of capacitive sensor electrodes 6 is positioned distal from the first edge 30 and from the second edge 32 of the sensing arrangement 5.

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The third array  $4_3$  of capacitive sensor electrodes 6 is positioned proximal to a second edge 32 of the sensing arrangement 5 and the fourth array  $4_4$  of capacitive sensor electrodes 6 is positioned distal from the first edge 30 and from the second edge 32 of the sensing arrangement 5.

The first conductive traces  $10_1$  extend parallel to a first direction (x) from the edge 30 into the first sensing area  $8_1$ . The first conductive traces  $10_1$  are separated in a second direction (y) (orthogonal to the x direction) so that the first conductive traces  $10_1$  are distributed over the first sensing area  $8_1$ .

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The third conductive traces  $10_3$  extend parallel to a first direction (x) from the second edge 32 into the third sensing area  $8_3$ . The third conductive traces  $10_3$  are separated in a second direction (y) (orthogonal to the x direction) so that the third conductive traces  $10_3$  are distributed over the third sensing area  $8_3$ .

The second conductive traces  $10_2$  extend, from the first edge 30, parallel to the first direction underneath the first sensing area  $8_1$  into the second sensing area  $8_2$ . The second conductive traces  $10_2$  are separated in a second direction (y) so that the second conductive traces  $10_2$  are distributed over the first sensing area  $8_1$  and the second sensing area  $8_2$ .

The second conductive traces  $10_2$  comprise conductive trace portions 18 that have a higher conductivity per unit length than the first conductive traces  $10_1$ .

The higher conductivity conductive trace portions 18 may, for example, be wider than the first conductive traces 10<sub>1</sub> where they extend across an area 19 overlapping the first array 4<sub>1</sub> of capacitive sensor electrodes 6.

The fourth conductive traces  $10_4$  extend, from the second edge 32, parallel to the first direction underneath the third sensing area  $8_3$  into the fourth sensing area  $8_4$ . The fourth conductive traces  $10_4$  are separated in a second direction (y) so that the second conductive traces  $10_2$  are distributed over the third sensing area  $8_3$  and the fourth sensing area  $8_4$ .

The fourth conductive traces  $10_4$  comprise conductive trace portions 18 that have a higher conductivity per unit length than the third conductive traces  $10_3$ .

The higher conductivity conductive trace portions 18 may, for example, be wider than the third (or first) conductive traces 10<sub>3</sub> where they extend across an area 19' overlapping the third array 4<sub>3</sub> of capacitive sensor electrodes 6.

In this example, the second conductive traces  $10_2$  are routed 18 underneath the first array  $4_1$  of capacitive sensor electrodes 6 and thus extend across an area overlapping the first array  $4_1$  of capacitive sensor electrodes 6. The fourth conductive traces  $10_4$  are routed 18 underneath the third array  $4_3$  of capacitive sensor electrodes 6 and thus extend across an area 19' overlapping the third array  $4_3$  of capacitive sensor electrodes 6.

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Fig 6C illustrates in more detail an example, according to the third embodiment, of a configuration, in a lower layer  $16_2$ , of second conductive traces  $10_2$  operatively connected to the second array  $4_2$  of capacitive sensor electrodes 6.

- For clarity of illustration, only one row/column of the second array 4<sub>2</sub> of capacitive sensor electrodes 6 is explicitly illustrated and only some of the capacitive sensor electrodes 6 in that row/column are illustrated. Only the second conductive traces 10<sub>2</sub> operatively connected to the illustrated capacitive sensor electrodes 6 are explicitly illustrated.
- In Fig 6C, the second conductive traces 102 where they are routed underneath the first array 41 of capacitive sensor electrodes 6 comprise wider portions 18 that have a higher conductivity per unit length than the conductive traces in the first layer 161. The higher conductivity conductive trace portions 18 are, in this example, wider than the first conductive traces 101 where they extend across the area 19 overlapping the first array 41 of capacitive sensor electrodes 6. Bends in the second conductive traces 102 are used to route the higher conductivity portions 18 of the second conductive traces 102 underneath capacitive sensor electrodes 6 of the first array 41 of capacitive sensor electrodes 6
- Fig 6D illustrates in more detail an example, according to the third embodiment, of a configuration, in a lower layer 16<sub>2</sub>, of fourth conductive traces 10<sub>4</sub> operatively connected to the fourth array 4<sub>4</sub> of capacitive sensor electrodes 6.

For clarity of illustration, only one row/column of the fourth array  $4_4$  of capacitive sensor electrodes 6 is explicitly illustrated and only some of the capacitive sensor electrodes 6 in that row/column are illustrated. Only the fourth conductive traces  $10_4$  operatively connected to the illustrated capacitive sensor electrodes 6 are explicitly illustrated.

- In Fig 6D, the fourth conductive traces  $10_4$  where they are routed underneath the third array  $4_3$  of capacitive sensor electrodes 6 comprise wider portions 18' that have a higher conductivity per unit length than the conductive traces in the first layer  $16_1$ . The higher conductivity conductive trace portions 18' are, in this example, wider than the third conductive traces  $10_3$  where they extend across the area 19' overlapping the third array  $4_3$  of capacitive sensor electrodes 6. Bends in the fourth conductive traces  $10_4$  are used to route the higher conductivity portions 18' of the fourth conductive traces  $10_4$  underneath capacitive sensor electrodes 6 of the third array  $4_3$  of capacitive sensor electrodes 6.
- Referring back to Figs 1 and 2, the apparatus 2 may comprises a second shield electrode 20 underlying, in the sensing area 8, the conductive traces 10 and the capacitive sensor electrodes 6.

The second shield electrode 20 may be a continuous uninterrupted single layer electrode that underlies the first and second layers  $16_1$ ,  $16_2$ .

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Alternatively, the second shield electrode 20 may comprise electrodes that underlie the arrays of capacitive sensor electrodes 6 in the first layer  $16_1$  and may comprise electrodes, in a different layer, that underlie the arrays of capacitive sensor electrodes 6 in the second layer  $16_2$  That is the second shield electrode 20 may be a multi-layer electrode (occupying multiple layers) or a single layer electrode (occupying a single layer).

The first shield electrode 12 may be used to cover the conductive traces where they group, outside the sensing area 8, at the first and second edges 30, 32 and at the side 34. The first shield electrode 12 may be used to cover areas that lies outside the sensing area 8.

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The conductive traces 10, the capacitive sensor electrodes 6 and the second shield electrode 20 overlie, in this example, a display 40. As they overlie a display 40 they are preferably transparent.

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The first shield electrode 12, the conductive traces 10, the capacitive sensor electrodes 6 and the second shield electrode 20 may therefore be formed from conductive and transparent material. They may be formed from the same or similar material or mixtures of material. Examples of suitable conductive and transparent materials include, for example, Indium-Tin-Oxide (ITO), metal mesh, silver nanowires and carbon nanotube composite.

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In the above examples, the arrays 4 of capacitive sensor electrodes 6 are each arranged as a regular array and in combination form an array of capacitive sensor electrodes 6 that is an N row by M column regular array, with common fixed spacing between columns and common fixed spacing between rows. However, it should be appreciated that the arrays 4 of capacitive sensor electrodes 6 need not be regular arrays and may be any suitable distribution of capacitive sensor electrodes 6.

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In the illustrated examples, each capacitive sensor electrode 6 has an associated conductive trace  $10_n$  for conveying a signal generated by that capacitive sensor electrode 6 away from the sensor area 8. In the illustrated example, each capacitive sensor electrode 6 and its associated conductive trace  $10_n$  is physically connected. The capacitive sensor electrodes 6 and the associated conductive traces  $10_n$  may be arranged within a common plane  $16_m$ . They may, for example, be formed by patterning a planar layer of transparent conductive material.

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Fig 3 schematically illustrates a cross-section through the sensing arrangement 5 along a line corresponding to a capacitive sensor electrode 6.

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The first shield electrode 12 is operatively connected to a node 22. Operatively connected means that there is a signal path but they may or may not be directly physically connected. When the apparatus 2 is operational the node 22 is held at a constant potential such as, for example, ground potential. Circuitry 24 is configured to provide a reference voltage signal to the first shield electrode 12. The circuitry 24 could

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be a simple galvanic connection to ground provided by, for example, a housing, a ground plane or a chassis.

In this example, a second shield electrode 20 is present. It is also operatively connected to the node 22.

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Detection circuitry 26 is operatively connected between the first shield electrode 12 and the array 4 of capacitive sensor electrodes 6.

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A multiplexer 28 is operatively connected between the detection circuitry 26 and the array 4 of capacitive sensor electrodes 6. The multiplexer 28 is configured to isolate, for detection, each of the plurality of capacitive sensor electrodes 6 of the array 4.

Drive circuitry 29 is configured to provide an alternating voltage to the first shield electrode 12 and, if present, the second shield electrode 20.

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The drive circuitry 29 is configured to provide a time varying electric field at each of the capacitive sensor electrodes 6.

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The detection circuitry 26 is configured to detect a variation in capacitance arising from proximity of a user input device 42 to one or more of the plurality of capacitive sensor electrodes 6. The detection circuitry 26 may comprise a low-impedance charge amplifier.

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When the user's hand, or some other grounded user input device 42, is brought to the vicinity of the sensing area 8 of the apparatus 2, a capacitive current flows from the first shield electrode 12 through the detection circuitry 26 to one or more capacitive sensor electrodes 6. The charge amplifier in the detection circuitry 26 registers a charge displacement due to the current. The output of the charge amplifier is synchronously rectified and integrated, after which it is passed to an analog-to-digital converter and then provided as digital output 27 for processing in the digital domain.

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The drive voltage and the drive frequency typically range from 1 V to 10 V and from 10 to 200 kHz, respectively.

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Due to reasons of cost and size, a single charge amplifier and a single analog-to-digital converter may be used in the detection circuitry 26 for multiple capacitive sensor electrodes 6 and a multiplexer 28 may be used to isolate for sensing each capacitive sensor electrode 6 separately.

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Fig 7 illustrates an example of a method 100.

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At block 102, the method 100 comprises arranging capacitive sensor electrodes 6 for touch sensing over a sensing area 8 as 102A a first sub-set  $4_1$  of the capacitive sensor electrodes 6, distributed in a first layer

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 $16_1$  over a first sub-set  $8_1$  of the sensing area 8 and as 102B a second sub-set  $4_2$  of the capacitive sensor electrodes 6, distributed in a second layer  $16_2$  over a second sub-set  $8_2$  of the sensing area 8.

- Referring back to the previous examples described, the first sub-set 4<sub>1</sub> of the capacitive sensor electrodes 6 correspond to the first array 4<sub>1</sub> of the capacitive sensor electrodes 6. The second sub-set 4<sub>2</sub> of the capacitive sensor electrodes 6 corresponds to the second array 4<sub>2</sub> of the capacitive sensor electrodes 6. The first sub-set 8<sub>1</sub> of the sensing area 8 corresponds to the first sensing area 8<sub>1</sub>. The second sub-set 8<sub>2</sub> of the sensing area 8 corresponds to the second sensing area 8<sub>2</sub>.
- At block 104 the method 100 comprises routing first conductive traces 10<sub>1</sub> to the first sub-set 4<sub>1</sub> of the capacitive sensor electrodes 6 and second conductive traces 10<sub>2</sub> to the second sub-set 4<sub>2</sub> of the capacitive sensor electrodes 6.
- As described above, the second conductive traces 10<sub>2</sub> may be routed under the first sub-set 8<sub>1</sub> of the sensing area 8 to reach the second sub-set 8<sub>2</sub> of the sensing area 8.

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More highly conductive (e.g. wider) traces 18 may be used for the second conductive traces  $10_2$  under the first sub-set  $8_1$  of the sensing area 8 than for the first conductive traces  $10_1$  (see Figs 4C, 5C, 6C, 6D for examples). This keeps the electrical resistance of the second conductive traces  $10_2$  small to reduce resistance-capacitance (RC) delays and improve measurement speed.

Additional sub-sets  $4_n$  of the capacitive sensor electrodes 6, may be distributed in a layer  $16_m$  over a nth sub-set  $8_n$  of the sensing area 8. Conductive traces  $10_n$  may be routed to the sub-set  $4_n$  of the capacitive sensor electrodes 6. The conductive traces  $10_n$  may be routed underneath other sub-sets  $4_n$  of the capacitive sensor electrodes 6 in an overlying layer  $16_m$ . Referring back to the previous examples described, the nth sub-set  $4_n$  of the capacitive sensor electrodes 6 correspond to the third array  $4_n$  of the capacitive sensor electrodes 6 distributed in the first layer  $16_n$  (n=3, m=1) and the fourth array  $4_n$  of the capacitive sensor electrodes 6 distributed in the second layer  $16_n$  (n=4, m=2). The conductive traces  $10_n$  are routed underneath the sub-sets  $4_n$  of the capacitive sensor electrodes 6 in the overlying layer  $16_n$  (n'=1, m'=1).

Dividing the capacitive sensor electrodes 6 into arrays 4 may allow different routing configurations of the conductive traces 10 to their respective capacitive sensor electrodes 6 (there is a one-to-one mapping between conductive traces 10 and capacitive sensor electrodes 6). In the illustrated examples, the capacitive sensor electrodes 10 in an array are distributed in two-dimensions and occupy a single layer, each Is associated with a particular (x, y) co-ordinate. There is therefore a significant number of conductive traces 10 required (one for each co-ordinate). Different arrays may receive their conductive traces from different edges.

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Dividing the arrays 4 of capacitive sensor electrodes 6 into different layers allows different routing configurations of the conductive traces 10 to their respective capacitive sensor electrodes 6, as the routing in one layer is not necessarily constrained by the configuration of conductive traces 10 and capacitive sensor elements 6 in any other layer.

In the example of Figs 4A, 4B, 4C, 5A, 5B, 5C and 6A, 6B, 6C, 6D, the first layer 16<sub>1</sub> may be an upper layer or a lower layer compared to the second layer 16<sub>2</sub>.

Fig 8A illustrates the apparatus 2 embodied as a touch panel module 134 that comprises the sensing arrangement 5. The apparatus 2 is operable as a functional sensing arrangement 5 and, with additional components, as a functional display. The touch panel module 134 may be used in combination with a display 40 to form a touch screen display.

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Fig 8B illustrates the apparatus 2 embodied as a touch panel module 136 that comprises the sensing arrangement 5 and a display 40. The apparatus 2 is operable as a functional sensing arrangement 5 and as a functional display.

Fig 8C illustrates the apparatus 2 embodied as an electronic device 140 that at least comprises the sensing arrangement 5 and a display 40. The apparatus 2 is operable as a functional display 40 and a functional sensing arrangement 5. The electronic device 38 may, for example, additionally comprise a processor 138 that processes the output 27 of the detection circuitry 26.

As used here 'module' refers to a unit or apparatus that excludes certain parts/components that would be added by an end manufacturer or a user.

In this document reference to an area refers to a two-dimensional space defined by a plane of the x and y components of a touch input position. Reference to an area overlapping another area refers to an intersection of volumes produced by projecting the areas normal to that plane. If areas are overlapping the projected volumes intersect and if the areas do not overlap the projected volumes do not intersect. Reference to an area overlapping another area does not necessarily imply an ordering to layers or components, which may be described explicitly.

Operatively connected means connected in a manner that enables the required functionality (operation). Any number or combination of intervening elements can exist (including no intervening elements) between two items that are operatively connected..

Although embodiments of the present invention have been described in the preceding paragraphs with reference to various examples, it should be appreciated that modifications to the examples given can be made without departing from the scope of the invention as claimed.

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Features described in the preceding description may be used in combinations other than the combinations explicitly described.

Although functions have been described with reference to certain features, those functions may be performable by other features whether described or not.

Although features have been described with reference to certain embodiments, those features may also be present in other embodiments whether described or not.

- Whilst endeavoring in the foregoing specification to draw attention to those features of the invention believed to be of particular importance it should be understood that the Applicant claims protection in respect of any patentable feature or combination of features hereinbefore referred to and/or shown in the drawings whether or not particular emphasis has been placed thereon.
- 15 I/we claim:

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#### **CLAIMS**

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a sensing arrangement comprising:

a first array of capacitive sensor electrodes comprising a first plurality of distinct capacitive sensor electrodes distributed in a first layer over a first sensing area;

first conductive traces operatively connected to the first plurality of distinct capacitive sensor electrodes;

a second array of capacitive sensor electrodes comprising a second plurality of distinct capacitive sensor electrodes distributed in a second layer over a second sensing area, wherein the first layer and the second layer are different layers; and

second conductive traces operatively connected to the second plurality of distinct capacitive sensor electrodes.

- 2. An apparatus as claimed in claim 1, wherein the second conductive traces comprise conductive traces that have a higher conductivity per unit length than the first conductive traces.
  - 3. An apparatus as claimed in claim 1 or 2, wherein the second conductive traces comprise conductive traces that are wider than the first conductive traces.
  - 4. An apparatus as claimed in any preceding claim, wherein at least some of the second conductive traces extend across an area overlapping the first array of capacitive sensors.
  - 5. An apparatus as claimed in any preceding claim, wherein the second layer underlies the first layer.
  - 6. An apparatus as claimed in any preceding claim, wherein the first array of capacitive sensor electrodes is positioned proximal to a first edge of the sensing arrangement and the second array of capacitive sensor electrodes is positioned distal from the first edge of the sensing arrangement.
- 7. An apparatus as claimed in any preceding claim, wherein the second conductive traces are routed underneath the first array of capacitive sensor electrodes.
  - 8. An apparatus as claimed in claim 7, wherein the second conductive traces where they are routed underneath the first array of capacitive sensor electrodes are wider than the first conductive traces.
  - 9. An apparatus as claimed in any preceding claim, wherein the first sensing area and the second sensing area comprise non-overlapping portions,
- 10. An apparatus as claimed in any preceding claim, wherein the first sensing area and the second sensing40 area are non-overlapping.

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11. An apparatus as claimed in any preceding claim, wherein the first array of capacitive sensor electrodes is configured to sense at least two positional components of a touch input that positions the touch input within the first sensing area and wherein the second array of capacitive sensor electrodes configured to sense at least two positional components of a touch input that positions the touch input within the second sensing area.

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12. An apparatus as claimed in any preceding claim, comprising a third array of capacitive sensor electrodes comprising a third plurality of distinct capacitive sensor electrodes distributed over a third
 10 sensing area; and

third conductive traces operatively connected to the third plurality of distinct capacitive sensor electrodes.

- 13. An apparatus as claimed in claim 12, wherein the third array of capacitive sensor electrodes comprising a third plurality of distinct capacitive sensor electrodes is distributed in the first layer over a the third sensing area.
  - 14. An apparatus as claimed in claim 12 or 13, comprising: a fourth array of capacitive sensor electrodes comprising a fourth plurality of distinct capacitive sensor electrodes distributed, in the second layer over a fourth sensing area and fourth conductive traces operatively connected to the fourth plurality of distinct capacitive sensor electrodes.
  - 15. An apparatus as claimed in any of claims 12 or 13, wherein the first array and the third array are positioned adjacent opposing first and second edges.
- 25 16. An apparatus as claimed in claim 15, wherein the first conductive traces extend parallel to a first direction from the first edge into the first sensing area and wherein the third conductive traces extend parallel to the first direction from the second edge into the third sensing area.
- 17. An apparatus as claimed in claim 15 or 16, wherein the second conductive traces extend, from the first edge, parallel to the first direction underneath the first sensing area into the second sensing area and wherein the fourth conductive traces extend, from the second edge, parallel to the first direction underneath the third sensing area into the second sensing area.
- 18. An apparatus as claimed in any of claims 12 or 13, wherein the first array is positioned adjacent a first edge and the third array is positioned distal from the first edge and from an opposing third edge.
  - 19. An apparatus as claimed in claim 18, wherein the first conductive traces extend parallel to a first direction from an edge into the first sensing area and wherein the third conductive traces extend parallel to the first direction, from the first edge, along a side orthogonal to the first edge and from the side in a second direction, orthogonal to the first direction, into the third sensing area.

- 20. An apparatus as claimed in claim 18 or 19, wherein the second conductive traces extend, from the first edge, parallel to the first direction underneath the first sensing area into the second sensing area and wherein the fourth conductive traces extend, from the first edge, parallel to the first direction along a side orthogonal to the first edge and from the side parallel to the second direction, orthogonal to the first direction, into the fourth sensing area.
- 21. An apparatus as claimed in any preceding claim, comprising:

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- a first shield electrode overlying, in the sensing area, at least the conductive traces; and
- a second shield electrode underlying, in the sensing area, the conductive traces and the capacitive sensor electrodes.
  - 22. An apparatus as claimed in claim 21, comprising a common connection between first and second shield electrode.
  - 23. An apparatus as claimed in any of claims 21 or 22, wherein the second shield electrode is a continuous uninterrupted electrode.
- 24. An apparatus as claimed in any of claims 21, 22 or 23, wherein the capacitive sensor electrodes, the conductive traces and the second shield electrode are transparent.
  - 25. An apparatus as claimed in any of claims 21 to 24 comprising detection circuitry connected between the first shield electrode and the capacitive sensor electrodes.
- 26. An apparatus as claimed in claim 25 comprising a multiplexer connected between the detection circuitry and the capacitive sensor electrodes, wherein the multiplexer is configured to isolate, for detection, each of the plurality of capacitive sensor electrodes of the array.
- 27. An apparatus as claimed in claim 25 or 26, wherein the detection circuitry comprises a low-impedance charge amplifier.
  - 28. An apparatus as claimed in any of claims 21 to 27, comprising circuitry configured to provide a reference voltage signal to the first shield electrode.
- 35 29. An apparatus as claimed in claim 28, wherein the circuitry is configured to provide an alternating voltage to the first shield electrode.
  - 30. An apparatus as claimed in any of claims 21 to 29, comprising drive circuitry configured to provide a time varying electric field at each of the capacitive sensor electrodes and detection circuitry configured to

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detect a variation in capacitance arising from proximity of a user input device to one or more of the plurality of capacitive sensor electrodes.

- 31. An apparatus as claimed in claim 30, wherein the detection circuitry is configured to detect a variation in capacitance arising from proximity of a user input device at or over a touch surface.
  - 32. An apparatus as claimed in claim 30 or 31 wherein the user input device is a user finger.
  - 33. An apparatus as claimed in any preceding claim embodied as a touch panel module.
  - 34. An apparatus as claimed in any preceding claim embodied as a touch sensitive display module.
  - 35. An apparatus as claimed in any preceding claim embodied as an electronic device.
    - 36. A method comprising:

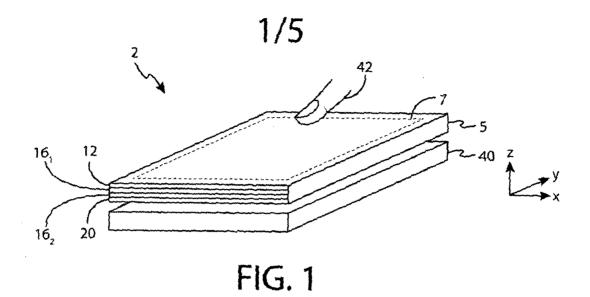
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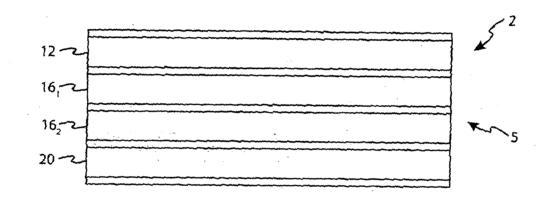
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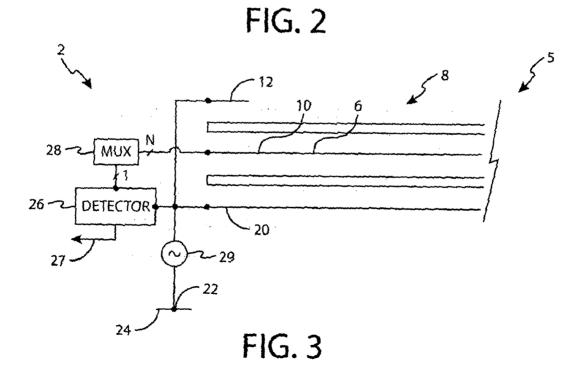
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- arranging capacitive sensor electrodes for touch sensing over a sensing area as a first sub-set of the capacitive sensor electrodes, distributed in a first layer over a first sub-set of the sensing area and as second sub-set of the capacitive sensor electrodes, distributed in second layer over a second sub-set of the sensing area; and
- routing first conductive traces to the first sub-set of the capacitive sensor electrodes and second conductive traces to the second sub-set of the capacitive sensor electrodes.
- 37. A method as claimed in claim 36 comprising routing the second conductive traces under the first subset of the sensing area to reach the second sub-set of the sensing area.
  - 38. A method as claimed in claim 36 or 37, comprising using wider traces for the second conductive traces under the first sub-set of the sensing area than for the first conductive traces.







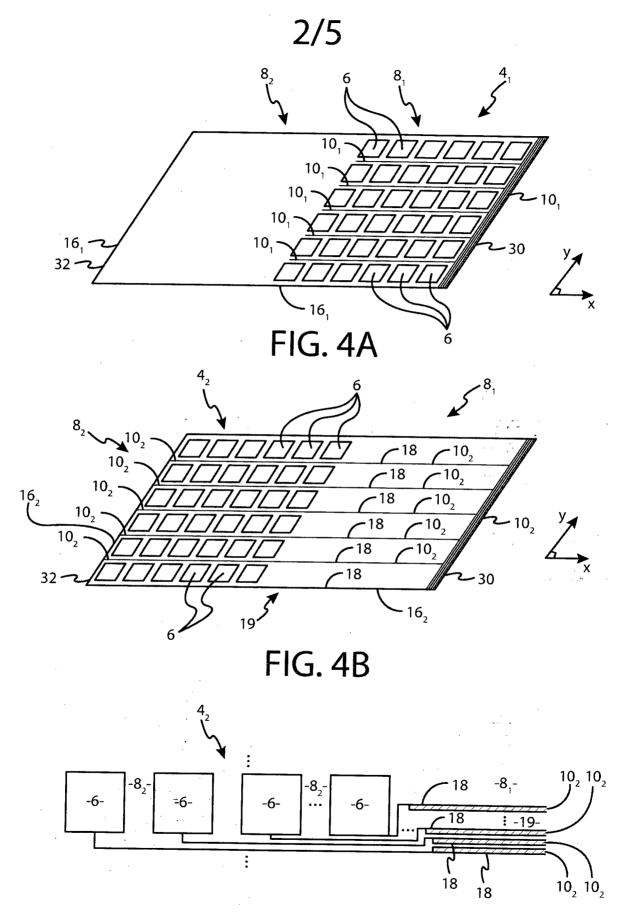


FIG. 4C

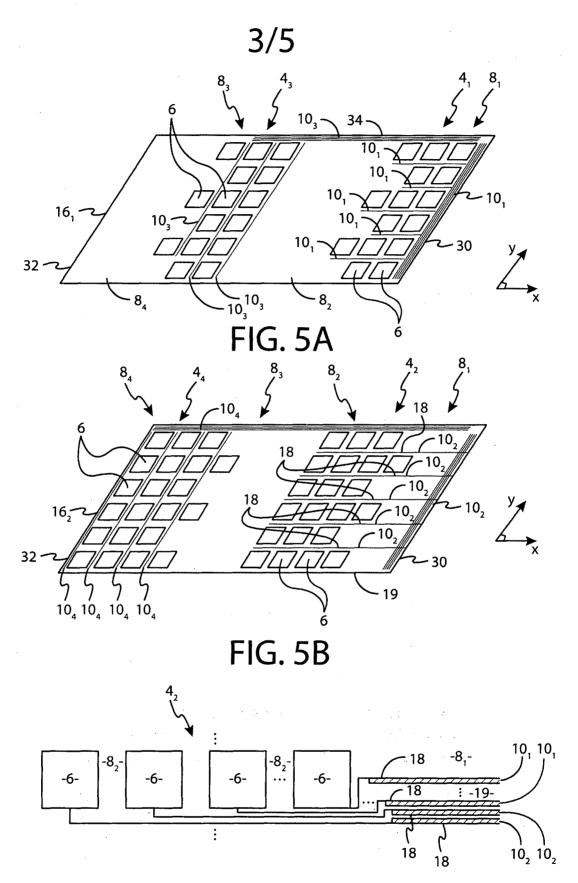
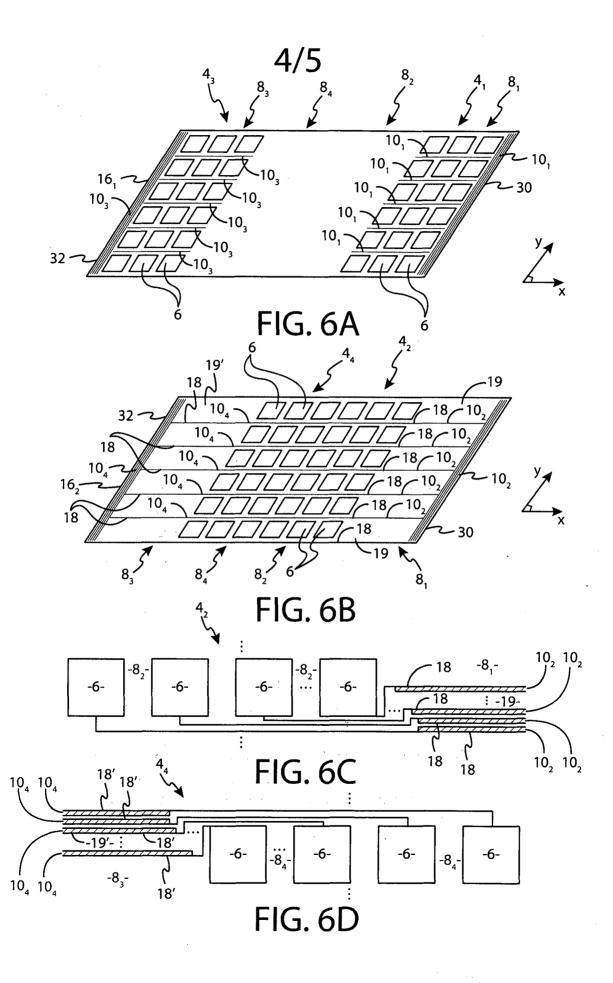
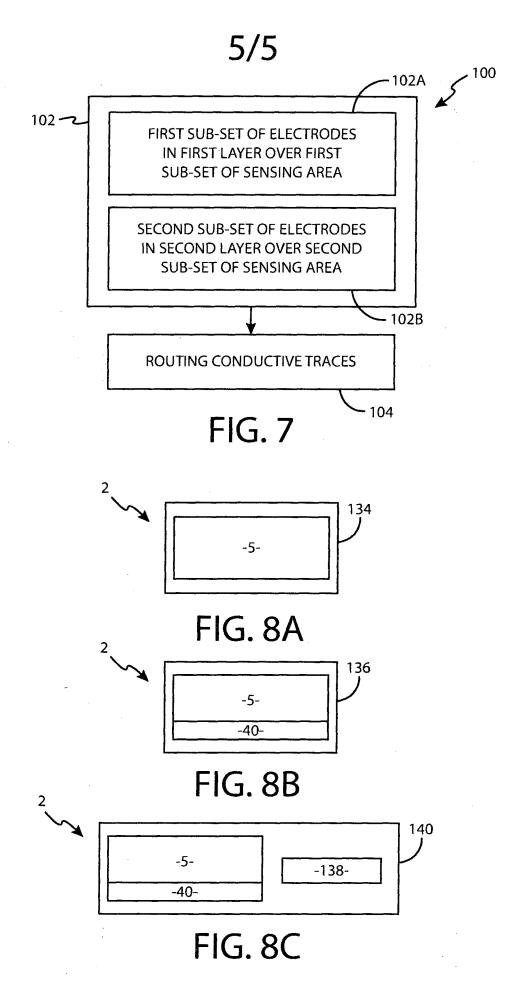


FIG. 5C





#### INTERNATIONAL SEARCH REPORT

International application No.

PCT/FI2013/050512

### A. CLASSIFICATION OF SUBJECT MATTER

#### See extra sheet

According to International Patent Classification (IPC) or to both national classification and IPC

#### B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC: G06F, H03K, H01L, G01D

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched FI, SE, NO, DK

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used) EPO-Internal, WPI, COMPDX, INSPEC, TDB, NPL, Internet

#### C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Х	US 2009085891 A1 (YANG TUN-CHUN [TW] et al.) 02 April 2009 (02.04.2009) abstract; paragraphs [0034], [0037]-[0038], [0040]-[0042], [0051]; figures 3-11	1-38
X	US 2010123681 A1 (WU YUAN-CHUN [TW] et al.) 20 May 2010 (20.05.2010) abstract; paragraphs [0011], [0062], [0065]-[0066], [0070], [0074]; figures 3-4, 6, 8	1, 36
X	US 2009273570 A1 (DEGNER BRETT WILLIAM [US] et al.) 05 November 2009 (05.11.2009) abstract; paragraphs [0040], [0042], [0046]-[0047], [0050], [0052], [0063], [0072]; figures 3-8	1,36

×	Further documents are listed in the continuation of Box C.	×	See patent family annex.
*	Special categories of cited documents:	"T"	later document published after the international filing date or priority
"A"	document defining the general state of the art which is not considered to be of particular relevance		date and not in conflict with the application but cited to understand the principle or theory underlying the invention
"E"	earlier application or patent but published on or after the international filing date	"X"	document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive
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Date	of the actual completion of the international search	Date	of mailing of the international search report
	05 May 2014 (05.05.2014)		06 May 2014 (06.05.2014)
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### INTERNATIONAL SEARCH REPORT

C (Continua	tion). DOCUMENTS CONSIDERED TO BE RELEVANT	
Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
Х	US 2012075249 A1 (HOCH DAVID [US]) 29 March 2012 (29.03.2012) abstract; paragraphs [0040]-[0042], [0061]-[0063], [0067]-[0069]; figures 2-5, 7-8	1, 36
A	WO 2012053498 A1 (GUNZE KK [JP]) 26 April 2012 (26.04.2012) & US 2013162596 A1 (KONO KATSUMASA [JP] et al.) 27.06.2013 paragraphs [0037], [0049], [0062]-[0063]; figures 1-2, 3c, 5-6, 9-11 of the US-document	
A	JP 2011154950 A (GUNZE KK) 11 August 2011 (11.08.2011) figures 1-2 & machine translation into English by Thomson Thomson [online] EPOQUENET TXTJPS paragraph [0033]	
A	US 2010201647 A1 (VERWEG FRANS [NL]) 12 August 2010 (12.08.2010) abstract; paragraphs [0021], [0030]-[0031], [0047], [0059], [0073]-[0076], [0089]; figures 5a-b	
Α	EP 2141573 A2 (APPLE INC [US]) 06 January 2010 (06.01.2010) abstract; paragraph [0100], [0158]; figures 6A-B	
Α	US 2012075215 A1 (YEH I-HAU [TW]) 29 March 2012 (29.03.2012) abstract; figure 2	
A	US 2010214247 A1 (TANG TUNG-YANG [TW] et al.) 26 August 2010 (26.08.2010) abstract; figures 1-10	
A	US 2011007021 A1 (BERNSTEIN JEFFREY TRAER [US] et al.) 13 January 2011 (13.01.2011) abstract; figure 1B	
A	US 5457289 A (HUANG HUNG-CHIH [US] et al.) 10 October 1995 (10.10.1995) abstract; column 3, lines 15-50; figure 4	

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
US 2009085891 A1	02/04/2009	TW 200915160 A	01/04/2009
US 2010123681 A1	20/05/2010	TW 201020871 A	01/06/2010
		TW 1376623 B	11/11/2012
US 2009273570 A1	05/11/2009	US 8629841 B2	14/01/2014
		CN 102016775 A	13/04/2011
		EP 2294502 A1 WO 2009134727 A1	16/03/2011 05/11/2009
		WO 2009134727 AT	05/11/2009
US 2012075249 A1	29/03/2012	AT 440426 T	15/09/2009
		AU 2010208183 A1	08/09/2011
		AU 2010208294 A1	08/09/2011
		AU 2010208296 A1	08/09/2011
		AU 2010208297 A1	08/09/2011
		AU 2010208314 A1	08/09/2011
		AU 2010208316 A1 AU 2010208317 A1	08/09/2011 08/09/2011
		AU 2010208317 A1 AU 2010208483 A1	08/09/2011
		AU 2010208484 A1	08/09/2011
		AU 2010208485 A1	08/09/2011
		AU 2010208486 A1	08/09/2011
		AU 2010208488 A1	08/09/2011
		AU 2010208489 A1	08/09/2011
		AU 2010208543 A1	08/09/2011
		AU 2010208544 A1	08/09/2011
		AU 2010208545 A1	08/09/2011
		AU 2010208545 B2	19/09/2013
		AU 2010208546 A1	08/09/2011
		AU 2010208547 A1	08/09/2011
		AU 2010208551 A1	08/09/2011
		AU 2010208552 A1	08/09/2011
		AU 2010208553 A1 AU 2010208554 A1	08/09/2011 08/09/2011
		AU 2010208556 A1	08/09/2011
		AU 2010208557 A1	08/09/2011
		AU 2010208557 B2	20/03/2014
		AU 2010208558 A1	08/09/2011
		AU 2010208565 A1	08/09/2011
		AU 2011258873 A1	06/12/2012
		AU 2011258874 A1	06/12/2012
		AU 2011299015 A1	14/03/2013
		AU 2011305456 A1	28/03/2013
		AU 2011305585 A1	28/03/2013
		AU 2011312169 A1	04/04/2013

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		AU 2011312872 A1	04/04/2013
		AU 2011312874 A1	04/04/2013
		AU 2011314086 A1	04/04/2013
		AU 2011336382 A1	27/06/2013
		AU 2011336453 A1	27/06/2013
		AU 2012239975 A1	24/10/2013
		CA 2562469 A1	07/04/2007
		CA 2764888 A1	29/12/2010
		CA 2786746 A1	05/08/2010
		CA 2786749 A1	05/08/2010
		CA 2786752 A1	05/08/2010
		CA 2786815 A1	05/08/2010
		CA 2786825 A1	05/08/2010
		CA 2786828 A1	05/08/2010
		CA 2786830 A1	05/08/2010
		CA 2786832 A1	05/08/2010
		CA 2786864 A1	05/08/2010
		CA 2786865 A1	05/08/2010
		CA 2786868 A1	05/08/2010
		CA 2786870 A1	05/08/2010
		CA 2786873 A1	05/08/2010
		CA 2786875 A1	05/08/2010
		CA 2786876 A1	05/08/2010
		CA 2786878 A1	05/08/2010
		CA 2786881 A1	05/08/2010
		CA 2786884 A1	05/08/2010
		CA 2786886 A1	05/08/2010
		CA 2786887 A1	05/08/2010
		CA 2786892 A1	05/08/2010
		CA 2786893 A1	05/08/2010
		CA 2786894 A1 CA 2786899 A1	05/08/2010
		CA 2786899 A1 CA 2787061 A1	05/08/2010
			05/08/2010
		CA 2787066 A1	05/08/2010
		CA 2800184 A1	01/12/2011
		CA 2800482 A1	01/12/2011
		CA 2810066 A1	15/03/2012
		CA 2811230 A1	29/03/2012
		CA 2811577 A1	29/03/2012
		CA 2813026 A1	19/04/2012
		CA 2813071 A1	12/04/2012
		CA 2813073 A1	12/04/2012
		CA 2813321 A1	12/04/2012
		CA 2819634 A1	07/06/2012
		CA 2819643 A1	07/06/2012
		CA 2825441 A1	02/08/2012
		CA 2832186 A1	11/10/2012
		CA 2832437 A1	11/10/2012
		CN 102342052 A	01/02/2012

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		CN 102362539 A	22/02/2012
		CN 102349065 A	08/02/2012
		CN 102356596 A	15/02/2012
		CN 102356581 A	15/02/2012
		CN 102362479 A	22/02/2012
		CN 102365630 A	29/02/2012
		CN 102365853 A	29/02/2012
		CN 102483730 A	30/05/2012
		CN 102365642 A	29/02/2012
		CN 102365631 A	29/02/2012
		CN 102365554 A	29/02/2012
		CN 102365876 A	29/02/2012
		CN 102365632 A	29/02/2012
		CN 102365620 A	29/02/2012
		CN 102365855 A	29/02/2012
		CN 102365840 A	29/02/2012
		CN 102365842 A	29/02/2012
		CN 102365623 A	29/02/2012
		CN 102365623 B	20/03/2013
		CN 102365643 A	29/02/2012
		CN 102365633 A	29/02/2012
		CN 102365877 A	29/02/2012
		CN 102365890 A	29/02/2012
		CN 102365847 A	29/02/2012
		CN 102365878 A	29/02/2012
		CN 102365858 A	29/02/2012
		CN 102802916 A	28/11/2012
		CN 103038651 A	10/04/2013
		CN 103038652 A	10/04/2013
		CN 103221941 A	24/07/2013
		CN 103202007 A	10/07/2013
		CN 103201730 A	10/07/2013
		CN 103221943 A	24/07/2013
		CN 103329119 A	25/09/2013
		CN 103250401 A	14/08/2013
		CN 103430166 A	04/12/2013
		DE 102009030492 A1	05/01/2011
		DE 602005016123 D1	01/10/2009
		EP 1773005 A1	11/04/2007
		EP 1773005 B1	19/08/2009
		EP 1773005 B8	14/10/2009
		EP 2391947 A1	07/12/2011
		EP 2391948 A1	07/12/2011
		EP 2391949 A1	07/12/2011
		EP 2391965 A1	07/12/2011
		EP 2394181 A1	14/12/2011
		EP 2392153 A1	07/12/2011
		EP 2392124 A1	07/12/2011
		EP 2391950 A1	07/12/2011

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		EP 2392126 A1	07/12/2011
		EP 2391940 A1	07/12/2011
		EP 2392154 A1	07/12/2011
		EP 2392129 A1	07/12/2011
		EP 2391942 A1	07/12/2011
		EP 2391977 A1	07/12/2011
		EP 2391966 A1	07/12/2011
		EP 2392170 A1	07/12/2011
		EP 2392109 A1	07/12/2011
		EP 2391951 A1	07/12/2011
		EP 2392102 A1	07/12/2011
		EP 2392088 A1	07/12/2011
		EP 2392090 A1	07/12/2011
		EP 2391952 A1	07/12/2011
		EP 2392182 A1	07/12/2011
		EP 2392094 A1	07/12/2011
		EP 2392155 A1	07/12/2011
		EP 2392121 A1	07/12/2011
		EP 2445698 A2	02/05/2012
		EP 2445698 B1	24/04/2013
		EP 2577332 A1	10/04/2013
		EP 2577333 A1	10/04/2013
		EP 2614446 A1	17/07/2013
		EP 2619684 A1	31/07/2013
		EP 2619970 A1	31/07/2013
		EP 2622503 A1	07/08/2013
		EP 2622506 A1	07/08/2013
		EP 2625626 A2	14/08/2013
		EP 2622835 A1	07/08/2013
		EP 2646903 A1	09/10/2013
		EP 2646930 A1	09/10/2013
		EP 2668584 A2	04/12/2013
		EP 2695037 A1	12/02/2014
		EP 2695085 A1 WO 2010149336 A2	12/02/2014 29/12/2010
		ES 2414539 T3	19/07/2013
		JP 2012530625 A	
		JP 2012530625 A JP 2013534081 A	06/12/2012 29/08/2013
		JP 2013534061 A JP 2013530640 A	25/07/2013
		JP 2013530640 A JP 2013541278 A	07/11/2013
		JP 2013541278 A JP 2013543676 A	05/12/2013
		JP 2013545323 A	19/12/2013
		JP 2014502066 A	23/01/2014
		JP 2013546212 A	26/12/2013
		JP 2014500989 A	16/01/2014
		JP 2014502383 A	30/01/2014
		KR 20110110829 A	07/10/2011
		KR 20110116189 A	25/10/2011
		KR 20110124258 A	16/11/2011

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		KR 20110110830 A	07/10/2011
		KR 20110124259 A	16/11/2011
		KR 20110110831 A	07/10/2011
		KR 20110110360 A	06/10/2011
		KR 20110108416 A	05/10/2011
		KR 20110124260 A	16/11/2011
		KR 20110110832 A	07/10/2011
		KR 20110126638 A	23/11/2011
		KR 20110113192 A	14/10/2011
		KR 20110116190 A	25/10/2011
		KR 20110117200 A	26/10/2011
		KR 20110110833 A	07/10/2011
		KR 20110124261 A	16/11/2011
		KR 20110110834 A	07/10/2011
		KR 20110113640 A	17/10/2011
		KR 20110110835 A	07/10/2011
		KR 20110110836 A	07/10/2011
		KR 20110116191 A	25/10/2011
		KR 20110119763 A	02/11/2011
		KR 20110110837 A	07/10/2011
		KR 20110110838 A	07/10/2011
		KR 20110116192 A	25/10/2011
		KR 20110110839 A	07/10/2011
		KR 20120052197 A	23/05/2012
		KR 20130088041 A	07/08/2013
		KR 20130113344 A	15/10/2013
		KR 20130108328 A	02/10/2013
		KR 20130140678 A	24/12/2013
		KR 20140003409 A	09/01/2014
		KR 20130114663 A	18/10/2013
		KR 20130143693 A	31/12/2013
		KR 20130114664 A	17/10/2013
		KR 20140009171 A	22/01/2014
		MX 2012000071 A	30/04/2012
		MX 2012013658 A	28/05/2013
		MX 2012013659 A	03/06/2013
		MX 2013002587 A	04/11/2013
		MX 2013003476 A	30/10/2013
		MX 2013003624 A	02/12/2013
		MX 2013003771 A	02/12/2013
		NZ 594715 A	20/12/2013
		NZ 594725 A	27/09/2013
		NZ 594732 A	30/08/2013
		NZ 594753 A	27/09/2013
		NZ 594787 A	27/09/2013
		NZ 594788 A	30/08/2013
		NZ 594789 A	27/09/2013
		NZ 594793 A	27/09/2013
		NZ 594795 A	27/09/2013

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		NZ 594796 A	27/09/2013
		NZ 594798 A	27/09/2013
		NZ 594799 A	27/09/2013
		NZ 594800 A	27/09/2013
		NZ 594801 A	30/08/2013
		NZ 594803 A	25/10/2013
		NZ 594804 A	27/09/2013
		NZ 603631 A	25/10/2013
		NZ 603634 A	29/11/2013
		RU 2012102252 A	27/07/2013
		RU 2507068 C2	20/02/2014
		US 7480042 B1	20/01/2009
		US 2007081547 A1	12/04/2007
		US 7778269 B2	17/08/2010
		US 7742164 B1	22/06/2010
		US 2010191604 A1	29/07/2010
		US 8331901 B2	11/12/2012
		US 2010191575 A1	29/07/2010
		US 8250207 B2	21/08/2012
		US 8326958 B1	04/12/2012
		US 2010191612 A1	29/07/2010
		US 2010188975 A1	29/07/2010
		US 8270310 B2	18/09/2012
		US 2010188990 A1	29/07/2010
		US 8355337 B2	15/01/2013
		US 2010188991 A1	29/07/2010
		US 2010188992 A1	29/07/2010
		US 8675507 B2	18/03/2014
		US 2010188993 A1	29/07/2010
		US 2010188994 A1	29/07/2010
		US 8023425 B2	29/07/2010
		US 2010190470 A1	29/07/2010
		US 2010191846 A1	29/07/2010
		US 2010188995 A1	29/07/2010
		US 8630192 B2	14/01/2014
		US 2010191847 A1	29/07/2010
		US 8583781 B2	12/11/2013
		US 2010191576 A1	29/07/2010
		US 8321526 B2	27/11/2012
		US 2010192170 A1	29/07/2010
		US 2010192212 A1	29/07/2010
		US 2010191613 A1	29/07/2010
		US 8229812 B2	24/07/2012
		US 2010192120 A1	29/07/2010
		US 8270952 B2	18/09/2012
		US 2010192207 A1	29/07/2010
		US 2010199325 A1	05/08/2010
		US 8391834 B2	05/03/2013
		US 2010197267 A1	05/08/2010

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		US 8548428 B2	01/10/2013
		US 2010198939 A1	05/08/2010
		US 8402111 B2	19/03/2013
		US 2010197266 A1	05/08/2010
		US 8275830 B2	25/09/2012
		US 2010198698 A1	05/08/2010
		US 8406748 B2	26/03/2013
		US 2010195503 A1	05/08/2010
		US 8346225 B2	01/01/2013
		US 2010197268 A1	05/08/2010
		US 8340634 B2	25/12/2012
		US 2011085168 A1	14/04/2011
		US 8373854 B2	
		US 2010272079 A1	12/02/2013 28/10/2010
		US 8649391 B2	28/10/2010 11/02/2014
		WO 2010088072 A1 WO 2010088073 A1	05/08/2010
			05/08/2010
		WO 2010088074 A1	05/08/2010
		WO 2010088075 A1	05/08/2010
		WO 2010088076 A1	05/08/2010
		WO 2010088080 A1	05/08/2010
		WO 2010088081 A1	05/08/2010
		WO 2010088082 A1	05/08/2010
		WO 2010088083 A1	05/08/2010
		WO 2010088085 A1	05/08/2010
		WO 2010088086 A1	05/08/2010
		WO 2010088087 A1	05/08/2010
		WO 2010088094 A1	05/08/2010
		WO 2010088095 A1	05/08/2010
		WO 2010088096 A1	05/08/2010
		WO 2010088097 A1	05/08/2010
		WO 2010088098 A1	05/08/2010
		WO 2010088100 A1	05/08/2010
		WO 2010088101 A1	05/08/2010
		WO 2010088275 A1	05/08/2010
		WO 2010088277 A1	05/08/2010
		WO 2010088278 A1	05/08/2010
		WO 2010088295 A1	05/08/2010
		WO 2010088297 A1	05/08/2010
		WO 2010088298 A1	05/08/2010
		WO 2010088413 A1	05/08/2010
		WO 2011149532 A1	01/12/2011
		WO 2011149533 A1	01/12/2011
		WO 2012047273 A1	12/04/2012
		WO 2012047275 A1	12/04/2012
		WO 2012034080 A1	15/03/2012
		WO 2012040247 A1	29/03/2012
		WO 2012040398 A1	29/03/2012

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		WO 2012050937 A2	19/04/2012
		WO 2012047932 A2	12/04/2012
		WO 2012075323 A1	07/06/2012
		WO 2012075347 A1	07/06/2012
		WO 2012102827 A2	02/08/2012
		WO 2012139050 A1	11/10/2012
		WO 2012139072 A1	11/10/2012
		WO 2013112642 A2	01/08/2013
		WO 2013138203 A1	19/09/2013
		WO 2013138532 A1	19/09/2013
		WO 2014018425 A2	30/01/2014
		US 2012161373 A1	28/06/2012
		US 2011320588 A1	29/12/2011
		US 8635335 B2	21/01/2014
		US 2011314145 A1	22/12/2011
		US 8589541 B2	19/11/2013
		US 2013065551 A1	14/03/2013
		US 8626115 B2	07/01/2014
		US 2012096513 A1	19/04/2012
		US 2012087319 A1	12/04/2012
		US 2012084438 A1	05/04/2012
		US 2012089727 A1	12/04/2012
		US 2012084184 A1	05/04/2012
		US 2012101952 A1	26/04/2012
		US 2012167162 A1	28/06/2012
		US 2012221955 A1	30/08/2012
		US 2012088470 A1	12/04/2012
		US 2012089845 A1	12/04/2012
		US 8351898 B2	08/01/2013
		US 2012134291 A1	31/05/2012
		US 2012215911 A1	23/08/2012
		US 8606911 B2	10/12/2013
		US 2012192249 A1	26/07/2012
		US 8516552 B2	20/08/2013
		US 2012289147 A1	15/11/2012
		US 2012278722 A1	01/11/2012
		US 2012195206 A1	02/08/2012
		US 8437271 B2	07/05/2013
		US 2012196565 A1	02/08/2012
		US 8531986 B2	10/09/2013
		US 2012197792 A1	02/08/2012
		US 2012195222 A1	02/08/2012
		US 8467312 B2	18/06/2013
		US 2012195223 A1	02/08/2012
		US 8547872 B2	01/10/2013
		US 2012201133 A1	09/08/2012
		US 2012203677 A1	09/08/2012
		US 2012208496 A1	16/08/2012
		US 8478667 B2	02/07/2013

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		US 2012209750 A1	16/08/2012
		US 8385916 B2	26/02/2013
		US 2012210391 A1	16/08/2012
		US 8396458 B2	12/03/2013
		US 2012214441 A1	23/08/2012
		US 8406733 B2	26/03/2013
		US 2012294195 A1	22/11/2012
		US 8441989 B2	14/05/2013
		US 2012330829 A1	27/12/2012
		US 8634805 B2	21/01/2014
		US 2012310804 A1	06/12/2012
		US 2013006729 A1	03/01/2013
		US 2012317284 A1	13/12/2012
		US 8527630 B2	03/09/2013
		US 2013005322 A1	03/01/2013
		US 8688099 B2	01/04/2014
		US 2013006780 A1	03/01/2013
		US 2013003613 A1	03/01/2013
		US 8588110 B2	19/11/2013
		US 2013005299 A1	03/01/2013
		US 8666364 B2	04/03/2014
		US 2013040703 A1	14/02/2013
		US 2013045710 A1	21/02/2013
		US 2013065553 A1	14/03/2013
		US 8630617 B2	14/01/2014
		US 2013065578 A1	14/03/2013
		US 8634821 B2	21/01/2014
		US 2013072149 A1	21/03/2013
		US 8630611 B2	14/01/2014
		US 2013080607 A1	28/03/2013
		US 8631102 B2	14/01/2014
		US 2013096998 A1	18/04/2013
		US 8667571 B2	04/03/2014
		US 2013125219 A1	16/05/2013
		US 8639935 B2	28/01/2014
		US 2013107706 A1	02/05/2013
		US 2013102278 A1	25/04/2013
		US 8630630 B2	14/01/2014
		US 2013109378 A1	02/05/2013
		US 2013145422 A1	06/06/2013
		US 2013132578 A1	23/05/2013
		US 8639811 B2	28/01/2014
		US 2013133028 A1	23/05/2013
		US 8640198 B2	28/01/2014
		US 2013132854 A1 US 2013224877 A1	23/05/2013
		US 8659755 B2	29/08/2013
		US 2013238751 A1	25/02/2014 12/09/2013
		US 2013238761 A1	12/09/2013

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		US 2013238762 A1	12/09/2013
		US 2013238777 A1	12/09/2013
		US 2013196647 A1	01/08/2013
		US 2013304616 A1	14/11/2013
		US 2013215795 A1	22/08/2013
		US 2013227659 A1	29/08/2013
		US 8635678 B2	21/01/2014
		US 2013229951 A1	05/09/2013
		US 2013239194 A1	12/09/2013
		US 8695073 B2	08/04/2014
		US 2013231084 A1	05/09/2013
		US 2013235766 A1	12/09/2013
		US 8570908 B2	29/10/2013
		US 2013250768 A1	26/09/2013
		US 2013305322 A1	14/11/2013
		US 2014040975 A1	06/02/2014
		US 2014024340 A1	23/01/2014
		US 2014095706 A1	03/04/2014
		US 2014075567 A1	13/03/2014
		US 2014098671 A1	10/04/2014
		US 2014094159 A1	03/04/2014
WO 2012053498 A1	26/04/2012	CN 103168335 A JP 2012089305 A JP 2012129171 A KR 20130105660 A TW 201234245 A US 2013162596 A1	19/06/2013 10/05/2012 05/07/2012 25/09/2013 16/08/2012 27/06/2013
JP 2011154950 A	11/08/2011	None	
	11/08/2011	None CN 101833405 A TW 201030587 A	15/09/2010 16/08/2010
		CN 101833405 A	
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1	16/08/2010 07/01/2010
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1 AU 2009267044 B2	16/08/2010 07/01/2010 06/12/2012
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1 AU 2009267044 B2 CN 101630082 A	16/08/2010  07/01/2010 06/12/2012 20/01/2010
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1 AU 2009267044 B2 CN 101630082 A CN 201725120 U	07/01/2010 06/12/2012 20/01/2010 26/01/2011
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1 AU 2009267044 B2 CN 101630082 A CN 201725120 U JP 2011527787 A	07/01/2010 07/01/2010 06/12/2012 20/01/2010 26/01/2011 04/11/2011
US 2010201647 A1	12/08/2010	CN 101833405 A TW 201030587 A AU 2009267044 A1 AU 2009267044 B2 CN 101630082 A CN 201725120 U JP 2011527787 A JP 2014002788 A	16/08/2010 07/01/2010 06/12/2012 20/01/2010 26/01/2011 04/11/2011 09/01/2014

Patent document cited in search report	Publication date	Patent family members(s)	Publication date
		US 2010001973 A1	07/01/2010
		US 8508495 B2	13/08/2013
		WO 2010002929 A2	07/01/2010
		US 2013293513 A1	07/11/2013
US 2012075215 A1	29/03/2012	TW 201214252 A	01/04/2012
US 2010214247 A1	26/08/2010	JP 2010198615 A	09/09/2010
		KR 20100095400 A	30/08/2010
US 2011007021 A1	13/01/2011	AU 2010271353 A1	02/02/2012
		AU 2010271353 B2	30/01/2014
		CN 102483673 A	30/05/2012
		EP 2452256 A2	16/05/2012
		JP 2012533122 A	20/12/2012
		KR 20120044359 A	07/05/2012
		WO 2011005977 A2	13/01/2011
US 5457289 A	10/10/1995	None	

### INTERNATIONAL SEARCH REPORT

CLASSIFICATION OF SUBJECT MATTER
Int.Cl. <b>G06F 3/044</b> (2006.01) <b>H01L 23/522</b> (2006.01)